

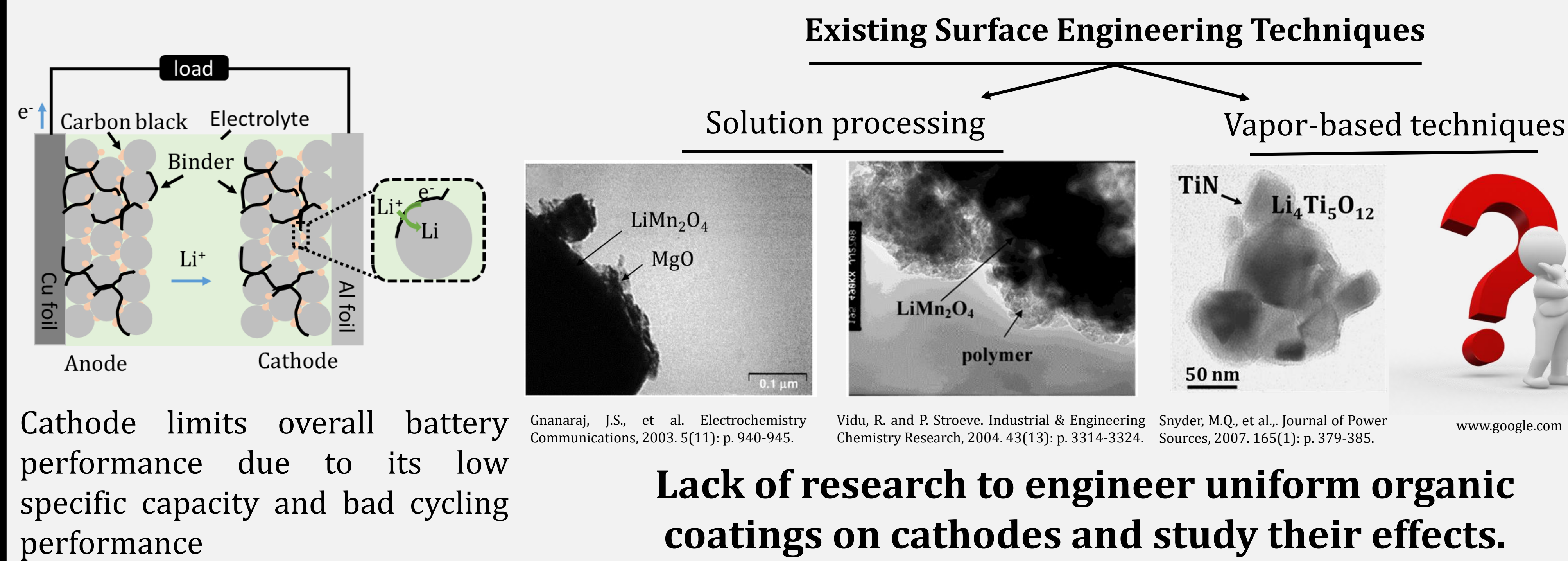


Surface Engineering of LiMn_2O_4 Electrode using Nanoscale Polymer Thin Film via Chemical Vapor Deposition Polymerization

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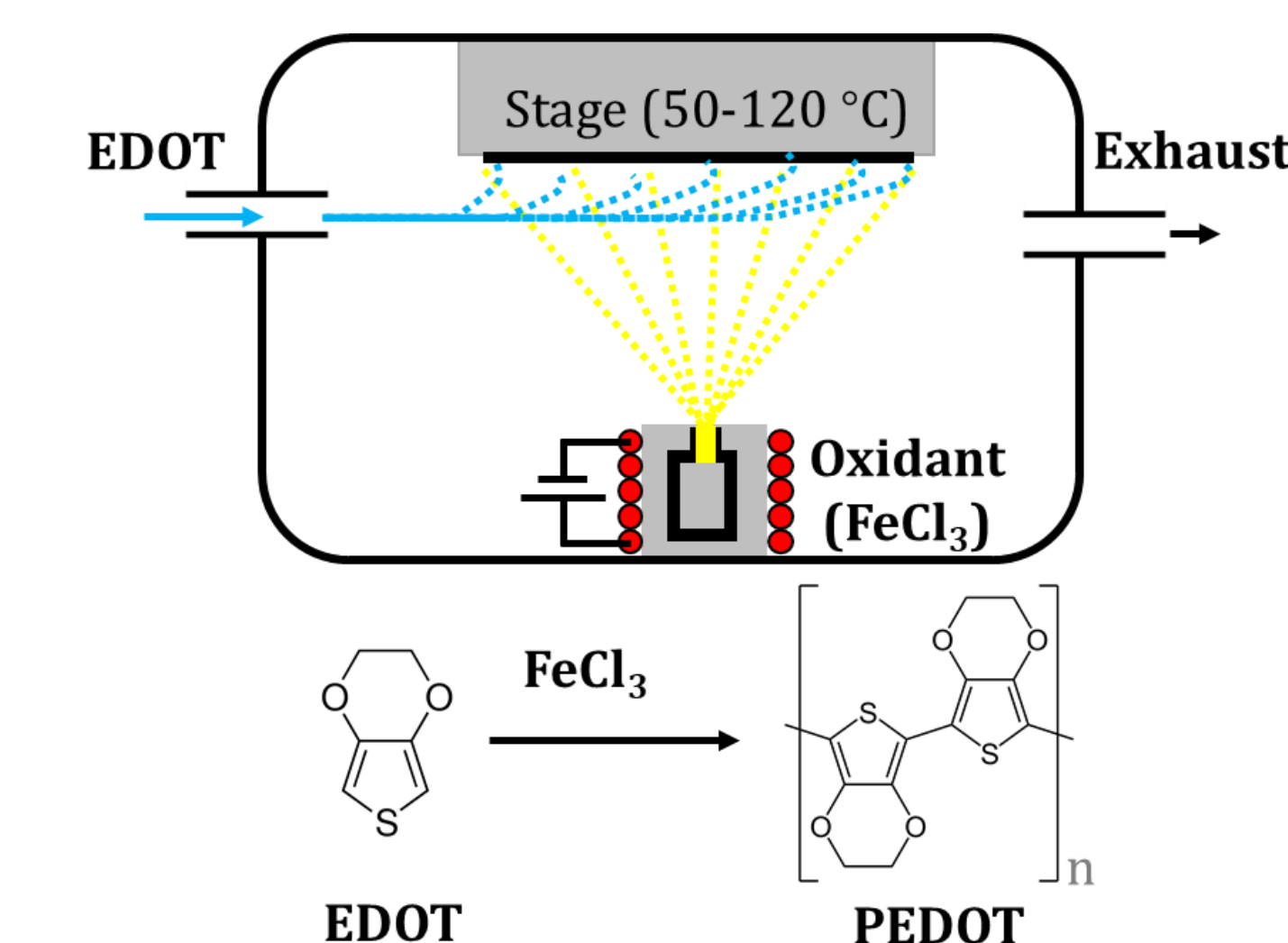
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Motivation

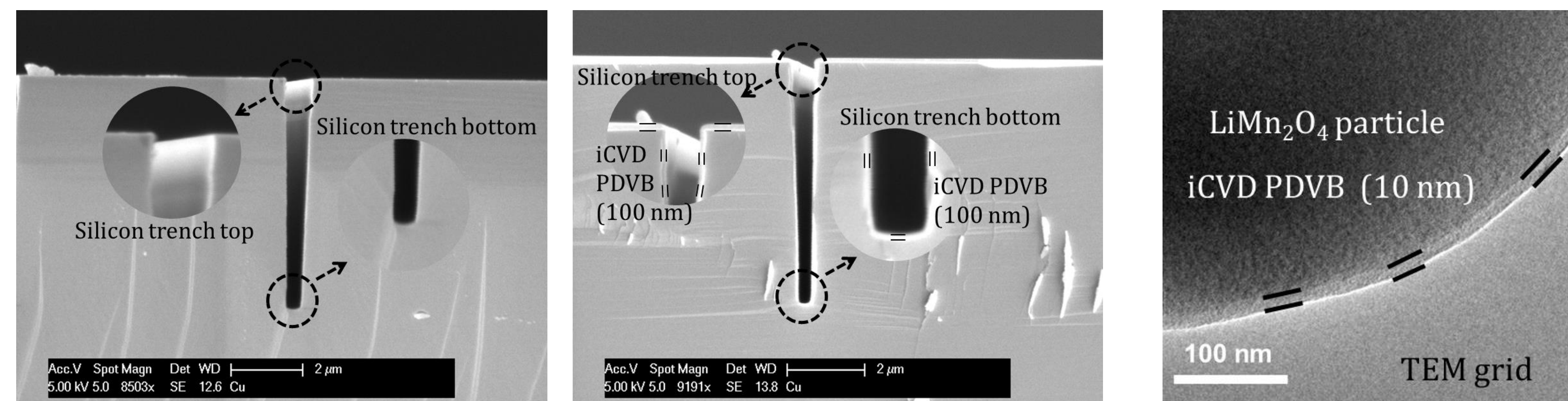
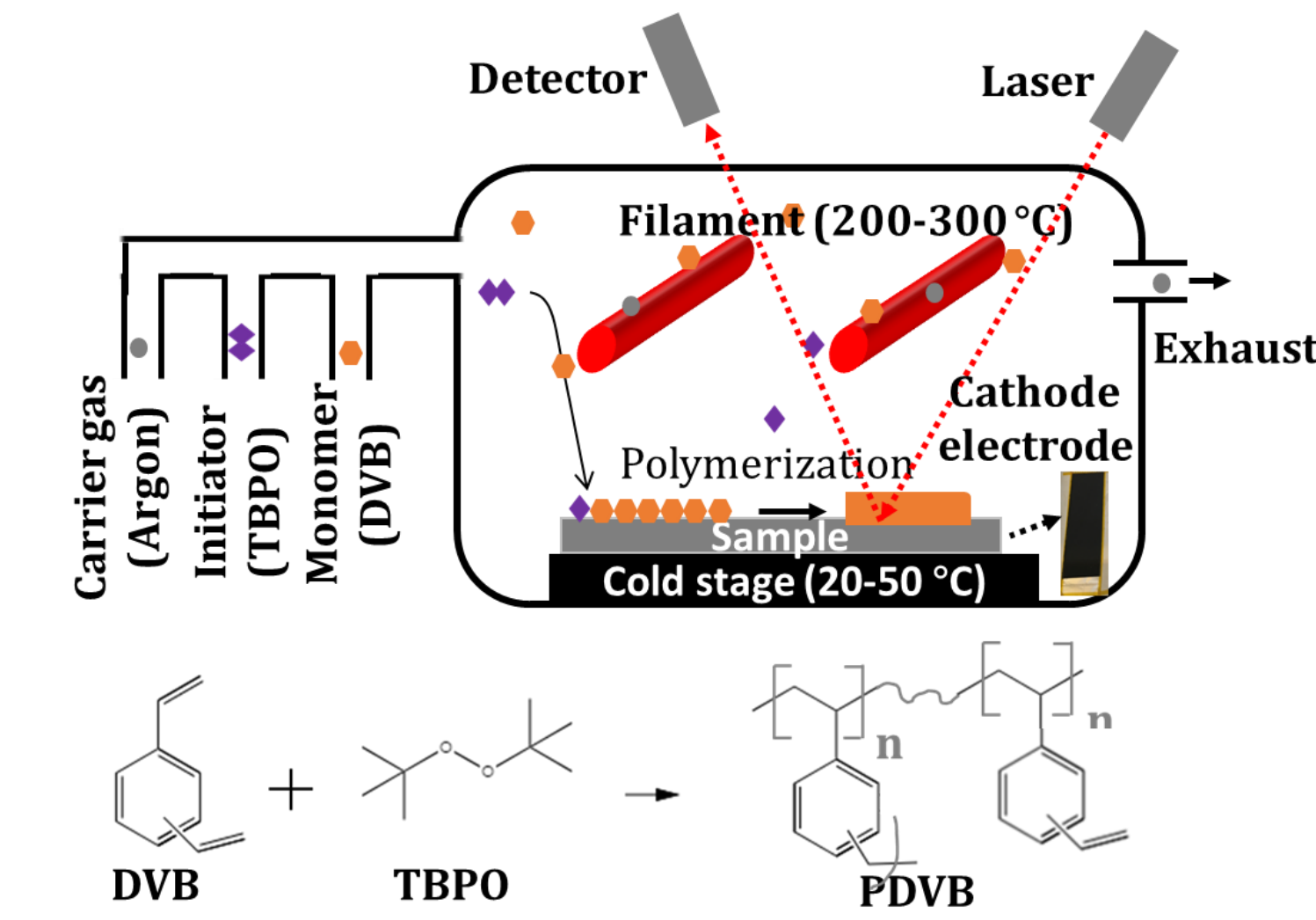


Chemical Vapor Deposition Polymerization

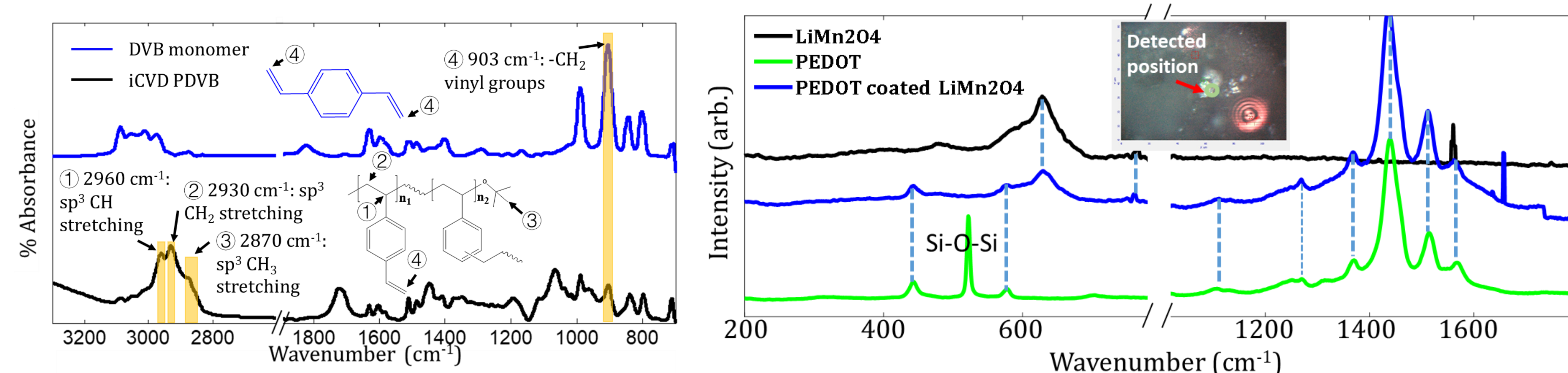
Oxidative chemical vapor deposition (oCVD)



Initiated chemical vapor deposition (iCVD)

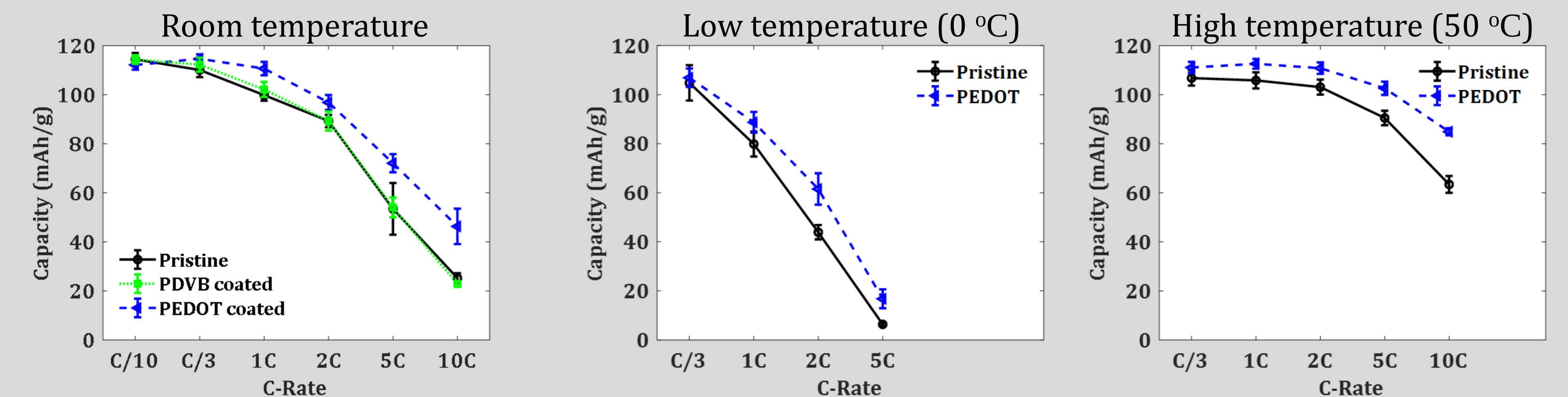


CVD technique can uniformly coat polymer thin film on complex structures, like silicon trenches and LiMn_2O_4 particles.

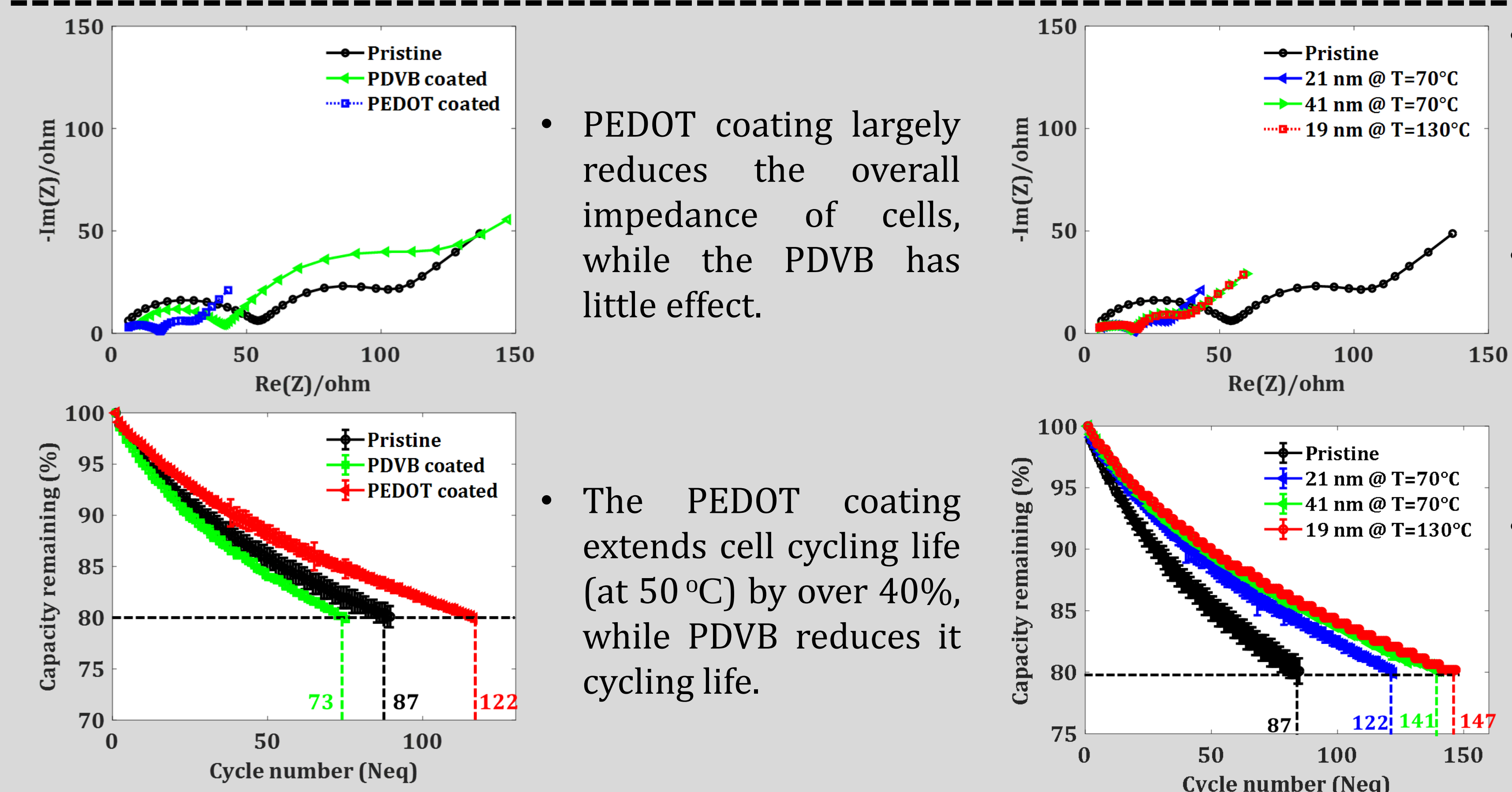


Successful polymerizations of PDVB & PEDOT were proven by FTIR and Raman spectroscopy.

Coin Cell Test Results

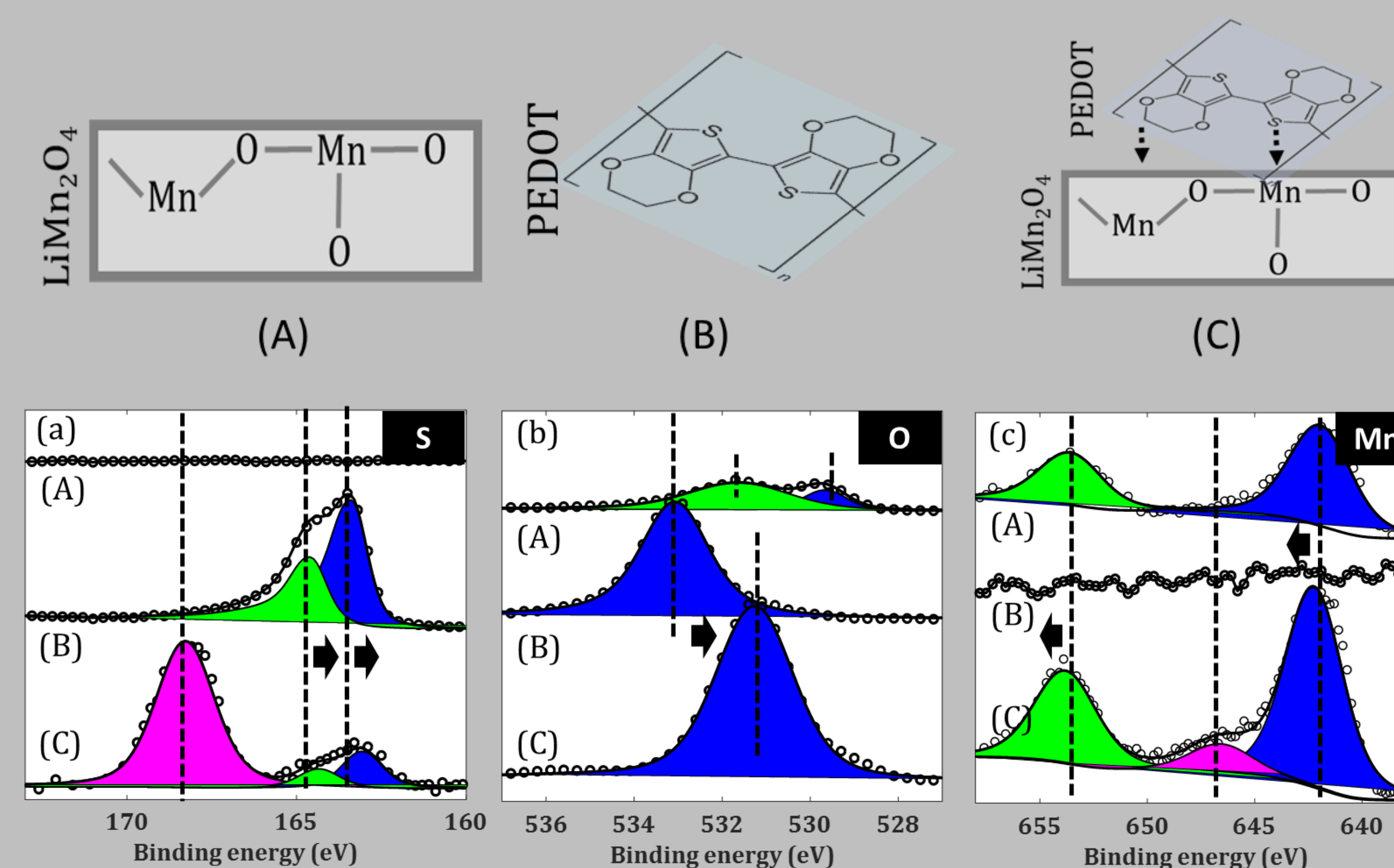


- The conductive PEDOT coating improves the rate capability of the LiMn_2O_4 electrode in a wide temperature range, the 10C capacity increases by 83% at 25 °C (from 23 to 42 mAh/g) and by 30% at 50 °C (from 64 to 83 mAh/g).
- In contrast, the insulating PDVB polymer does not improve the rate capability of the LiMn_2O_4 electrode.



- The effect of coating thickness and stage temperature are considered.
- The electrochemical impedance of the LiMn_2O_4 electrode is largely reduced by PEDOT coatings at all examined conditions.
- The cell lifespan is further extended by tuning the coating thickness and stage temperature during oCVD experiment.

X-ray Photoelectron Spectroscopy



- There are bonds formation between manganese in LiMn_2O_4 and oxygen and sulfur in PEDOT at the interface of the coating. These bonds further oxidize manganese on the surface of LiMn_2O_4 . Therefore, the stability of the LiMn_2O_4 is increased since extra energy is needed to destroy the spinel structure.

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